

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Mu-Tsang Lin

Group Art Unit: 2125

Serial No.: 10/789,969

Examiner: Carlos R. Ortiz

Rodriguez

Filed: 02/26/2004

In Response to Office Action

Dated: 02/09/2005

For:

TEMPERATURE-SENSING WAFER POSITION DETECTION

SYSTEM AND METHOD

Attorney Docket No.: 67,200-1230

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Va 22313-1450

Date: Apr. 27, 2005

athy Dixon

## RESPPONSE TO OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 02/09/2005 please enter the following amendments and consider the following remarks.